

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
California Institute of Technology	12/16/2010
RECEIVING PARTY DATA	
Name:	National Science Foundation
Street Address:	4201 Wilson Blvd
Internal Address:	Room 1265
City:	Arlington
State/Country:	VIRGINIA
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PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	12575312
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Total Attachments: 1 source=401#page1.tif	

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Invention Title: Characterization of Nanoscale Structures Using an Ultrafast Electron Microscope

Inventors: Ahmed H. Zewail

Patent Application Serial No: 12/575,312

US Filing/Issue Date: 10/7/2009

Grant/Contract Identification No: CHE0549936 & DMR0504854 & CHE0549936 & DMR0504854

Foreign Applications filed/intended in (countries):

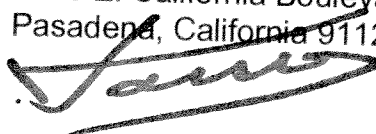
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The Government is here by granted an irrevocable power to inspect and make copies of the above-identified patent application.

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Dated: December 16, 2010



Fred Farina, Asst VP for Tech Transfer

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